



PATENT APPLICATION *IFan*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeyuki MIZUTANI

Group Art Unit: 2851

Application No.: 10/585,213

Filed: July 3, 2006

Docket No.: 128610

For: EXPOSURE METHOD AND APPARATUS, AND DEVICE MANUFACTURING
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application, and this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

John A. Radi
Registration No. 59,345

MAC:JAR/sqs
Date: October 23, 2007

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

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